

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S10	164	nishi near3 kenji and (stage or wafer)	US-PGPUB; USPAT	OR	OFF	2004/12/30 13:47
S11	42	nishi near3 kenji and (stage or wafer) and chamber	US-PGPUB; USPAT	OR	OFF	2004/12/30 14:00
S12	20	nishi near3 kenji and (stage or wafer) and chamber same second	US-PGPUB; USPAT	OR	OFF	2004/12/30 14:07
S13	246	(stage or wafer) and chamber same second same volume same vibrat\$6	US-PGPUB; USPAT	OR	OFF	2004/12/30 14:08
S14	91	stage and (wafer or exposur\$6 or lithograph\$4) and chamber same second same volume same vibrat\$6	US-PGPUB; USPAT	OR	OFF	2004/12/30 15:38
S15	6	gas near2 bearing and chamber same second same volume same vibrat\$6	US-PGPUB; USPAT	OR	OFF	2004/12/30 16:05
S16	1	gas near2 bearing and chamber with (upper or lower or bottom) same volume same vibrat\$6	US-PGPUB; USPAT	OR	OFF	2004/12/30 16:06
S17	2	gas near2 bearing and chamber with (upper or lower or bottom or second) same volume same vibrat\$6	USOCR; EPO; JPO; DERWENT	OR	OFF	2004/12/30 16:08
S18	29	gas near2 bearing and chamber with (upper or lower or bottom or second) same vibrat\$6	USOCR; EPO; JPO; DERWENT	OR	OFF	2004/12/30 16:09
S19	40	gas near2 bearing and chamber with (upper or lower or bottom or second) same vibrat\$6	US-PGPUB; USPAT	OR	OFF	2004/12/30 16:16
S20	50	gas near2 bearing and chamber with (chang\$4 or alter\$4) with volume	US-PGPUB; USPAT	OR	OFF	2004/12/30 16:17